

INFORMATION DISCLOSURE STATEMENT

PTO-1449 (PAGE 1 OF 1)

SERIAL NUMBER 10/698,433

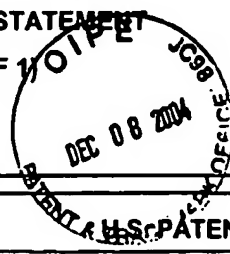
DOCKET NO. P56975

APPLICANT

JUNG-KEUN AHN, et al.

FILING DATE 3 November 2003

GROUP 1772



U.S. PATENT DOCUMENTS

EXAMINER	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE

FOREIGN PATENT DOCUMENTS

TRANSLATION

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	YES	NO
~	JP 2001-160360	6/01	JAPAN			Abstract	
~	JP 2001-236890	8/01	JAPAN			Abstract	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

~	Office Action from the Korean Industrial Property Office issued in Applicant's corresponding Korean Patent Application No. 10-2002-0068084 (dated 30 September 2004).

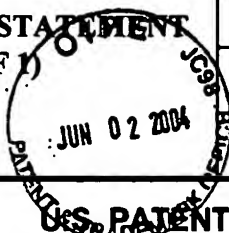
EXAMINER:

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DATE CONSIDERED:

10/17/05

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP §609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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				APPLICANT JUNG-KEUN AHN et al.			
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U.S. PATENT DOCUMENTS							
EXAMINER INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
u	RE37,444	11/01	Kanazawa	—	—		
✓	5,541,618	07/96	Shinoda	—	—		
✓	5,661,500	08/97	Shinoda et al.	—	—		
✓	5,663,741	09/97	Kanazawa	—	—		
✓	5,674,553	10/97	Sinoda et al.	—	—		
✓	5,724,054	03/98	Shinoda	—	—		
✓	5,786,794	07/98	Kishi et al.	—	—		
✓	5,952,782	09/99	Nanto	—	—		
✓	6,630,916	10/03	Shinoda	—	—		
✓	6,707,436	03/04	Setoguchi et al.	—	—		
FOREIGN PATENT DOCUMENTS						TRANSLATION	
	DOCUMENT NUMBER	DATE	COUNTRY	CLAS	SUBCLASS	YES	NO
✓	JP 2001-325888	11/01	JAPAN	—	—	Abstract	
✓	JP 2001-043804	02/01	JAPAN	—	—	Abstract	
✓	JP 2917279	04/99	JAPAN	—	—	Abstract	
✓	JP 02-148645	06/90					
✓	JP 2845183	10/98					
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
EXAMINER INITIALS	"Final Draft International Standard", Project No. 47C/61988-1/Ed.1; Plasma Display Panels - Part 1: Terminology and letter symbols, published by International Electrotechnical Commission, IEC. in 2003, and Appendix A - Description of Technology, Annex B - Relationship Between Voltage Terms And Discharge Characteristics; Annex C - Gaps and Annex D - Manufacturing						
EXAMINER: D. [Signature]				DATE CONSIDERED: 10/14/05			
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U.S. PATENT DOCUMENTS

EXAMINER	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE
ス	2002/0050788	5/02	Kimura et al.	1	1	
ル	6,166,711	12/00	Odake	1	1	
ル	6,400,079	6/02	Baret et al.	1	1	
ル	6,285,128	9/01	Amemiya	1	1	
ル	5,684,362	11/97	Togawa	1	1	
ル	6,400,080	6/02	Tanaka	1	1	
ス	5,886,467	3/99	Kimura	1	1	
ル	6,590,332	7/03	Park et al.	1	1	

FOREIGN PATENT DOCUMENTS

TRANSLATION

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	YES	NO
	JP2001-160360	6/01	Japan				

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, etc.)*

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